



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **Manabu NAKAMURA et al.**

Group Art Unit: **2891**

Application Number: **10/659,748**

Examiner: **Bradley Smith**

Filed: **September 11, 2003**

Confirmation Number: **3468**

For: **METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE  
HAVING GATE OR TUNNEL INSULATION FILM**

Attorney Docket Number: **031140**  
Customer Number: **38834**

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

April 18, 2006

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated November 18, 2005 for two month(s) from February 18, 2006 to April 18, 2006. (Applicants already paid \$120.00 for first month Extension of Time on March 16, 2006).

Applicants include a check including \$330.00 for the second month's extension. If any additional fees are due in connection with this paper, please charge our Deposit Account No. 50-2866.

Respectfully submitted,

**WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP**

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